- - (1) preparing a nanoparticle dispersion of ZnS doped with a luminescent centre by precipitation from appropriate aqueous solutions comprising zinc ions, sulfide ions and dopant ions,
 - (2) washing said dispersion of doped ZnS to remove nonprecipitated ions,
 either,
 - (3) mixing said washed dispersion of doped ZnS (n-type semiconductor) with a water-compatible p-type semiconductive polymer,
 - (4) coating said mixture, optionally after admixture with a binder, onto a first conductive electrode,
 - (5) applying on top of said coated layer resulting from step (4) a second conductive electrode, with the proviso that at least one of said first and second electrode is transparent,



or,

- (3') coating on top of a first conductive layer electrode a double layer pack comprising, in either order,
- (3'a) a layer containing a water-compatible p-type semiconductive polymer, and,
- (3'b) a layer containing said washed dispersion of doped ZnS, optionally admixed with a binder,
- (4') applying on top of said coated layer pack resulting from step (3') a second conductive electrode, with the proviso that at least one of said first and second conductive electrode is transparent.
- 2.(Original) A method according to claim 1 wherein said precipitation of step (1) is performed according to the double jet principle whereby a first solution containing zinc ions and a second solution containing sulfide ions are added together to a third solution.
- 3.(Original) A method according to claim 2 wherein said first solution also contains said dopant ions.
- 4.(Original) A method according to claim 1 wherein said dopant ions are manganese ions.

Tomo.

- 5.(Original) A method according to claim 1 wherein said dopant ions are copper(I) or copper(II) ions.
- 6.(Currently Amended)

 A method Method according to claim 1

 wherein said washing of said dispersion of doped ZnS is

 performed by an ultrafiltration step, and/an

 ultrafiltration step and said diafiltration step, or said

 diafiltration step.
- 7. (Currently Amended) A method Method according to claim 6
 wherein said ultrafiltration step, said ultrafiltration
 step and said diafiltration step, and/or said diafiltration
 step is (are) performed in the presence of a compound
 preventing agglomeration of nanoparticles.
- 8. (Original) A method according to claim 1 wherein said water-compatible p-type semiconductive polymer is a polythiophene/polymeric polyanion complex.
- 9. (Original) A method according to claim 8 wherein said polythiophene is poly(3,4-ethylenedioxythiophene).
- 10. (Original) A method according to claim 8 wherein said polymeric polyanion is polystyrene sulphonate.
- 11. (Original) A method according to claim 1 wherein said first electrode is an Indium Tin Oxide (ITO) electrode.

- 12. (Original) A method according to claim 1 wherein said second conductive electrode is an aluminum electrode applied by vacuum deposition.
- 13. (Currently Amended) A Thin Film Inorganic Light Emitting

 Diode device manufactured according to the a method of any

 of the previous claims for manufacturing a Thin Film

 Inorganic Light Emitting Diode device, said method

 comprising the following steps, in order:
- (1) preparing a nanoparticle dispersion of ZnS doped with a

 luminescent centre by precipitation from appropriate

 aqueous solutions comprising zinc ions, sulfide ions, and
 dopant ions,
- (2) washing said dispersion of doped ZnS to remove nonprecipitated ions,
- (3) mixing said washed dispersion of doped ZnS (n-type semiconductor) with a water-compatible p-type semiconductive polymer,
- (4) coating said mixture, optionally after admixture with a binder, onto a first conductive electrode,
- (5) applying on top of said coated layer resulting from step(4) a second conductive electrode, with the proviso that at

least one of said first and second conductive electrodes is transparent.

- 14 (New). A method for manufacturing a Thin Film Inorganic Light

 Emitting Diode device, said method comprising the following

 steps, in order:
 - (1) preparing a nanoparticle dispersion of ZnS doped with a luminescent centre by precipitation from appropriate aqueous solutions comprising zinc ions, sulfide ions and dopant ions,
 - (2) washing said dispersion of doped ZnS to remove nonprecipitated ions,
 - (3') coating on top of a first conductive layer a double layer pack comprising, in any order,
 - (3'a) a layer containing a water-compatible p-type semiconductive polymer, and,
 - (3'b) a layer containing said washed dispersion of doped ZnS, optionally admixed with a binder,
 - (4') applying on top of said coated layer pack resulting from step (3') a second conductive electrode, with the proviso that at least one of said first and second conductive electrodes is transparent.

- 15 (New). Method according to claim 14 wherein said precipitation of step (1) is performed according to the double jet principle whereby a first solution containing zinc ions and a second solution containing sulfide ions are added together to a third solution.
- 16 (New). Method according to claim 15 wherein said first solution also contains said dopant ions.
- 17 (New). Method according to claim 14 wherein said dopant ions are manganese ions.
- 18 (New). Method according to claim 14 wherein said dopant ions are copper(I) or copper(II) ions.
- 19 (New). Method according to claim 14 wherein said washing of said dispersion of doped ZnS is performed by an ultrafiltration step, an ultrafiltration step and a diafiltration step, or a diafiltration step.
- 20 (New). Method according to claim 19 wherein said ultrafiltration step, said ultrafiltration step and said diafiltration step, or said diafiltration step is (are) performed in the presence of a compound preventing agglomeration of nanoparticles.

- 21(New). Method according to claim 14 wherein said watercompatible p-type semiconductive polymer is a polythiophene/polymeric polyanion complex.
- 22(New). Method according to claim 21 wherein said polythiophene is poly(3,4-ethylenedioxythiophene).
- 23 (New). Method according to claim 21 wherein said polymeric polyanion is polystyrene sulphonate.
- 24(New). Method according to claim 14 wherein said first electrode is an Indium Tin Oxide (ITO) electrode.
- 25 (New). Method according to claim 14 wherein said second conductive electrode is an aluminum electrode applied by vacuum deposition.
- 26 (New). A Thin Film Inorganic Light Emitting Diode device
 manufactured according to a method for manufacturing a Thin
 Film Inorganic Light Emitting Diode device, said method
 comprising the following steps, in order:
 - (1) preparing a nanoparticle dispersion of ZnS doped with a luminescent centre by precipitation from appropriate aqueous solutions comprising zinc ions, sulfide ions and dopant ions,
 - (2) washing said dispersion of doped ZnS to remove non-

precipitated ions,

(3') coating on top of a first conductive layer a double layer pack comprising, in any order,

(3'a) a layer containing a water-compatible p-type semiconductive polymer, and,

(3'b) a layer containing said washed dispersion of doped ZnS, optionally admixed with a binder,

(4') applying on top of said coated layer pack resulting from step (3') a second conductive electrode, with the proviso that at least one of said first and second conductive electrodes is transparent.

Ary.